

Procedural Review Voting Sheet 2013 Cycle 7

REGION: **Japan**
 COMMITTEE: **Silicon Wafer**
 EVENT: **SEMICON Japan 2013**
 DATE OF MEETING: **12/5/2013**
 PLACE OF MEETING: **Makuhari Messe, Chiba, Japan**
 COMMITTEE CO-CHAIRS: **Tetsuya Nakai/SUMCO, Naoyuki Kawai/The University of Tokyo**
 SEMI STAFF: **Hirofumi Kanno**

A&R Voter: **Name/Company**
 Date: **200X/MM/DD**

I. Document Number & Title

Document 5389A	Document Title Revision to MF1982-1110, Test Methods for Analyzing Organic Contaminants on Silicon Wafer Surfaces by Thermal Desorption Gas Chromatography
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II. Tally (Staff to fill in)

Voting Tally: **As-cast tally after close of voting period**

A minimum of 60% of the voting interests that have voting members within the technical committee must return votes. (Regulations ¶ 9.6.1)

	Return		Distribution		Return Rate	
Yellow	56	÷	91	=	61.5%	>=60%
Lilac & Others	36					
Total Vote	92					
Reject	0					
Accept	21					

A&R		Not approved
		Reason:

III. Rejects

None

IV. Comments

Comment 1

Comment	Referenced Section	*TF/Committee to fill in if necessary	
	From	Kurt Haler (KLA-Tencor)	
	Comment	Accept with comment: Editorial: Formatted text for Cn definition is unreadable. Letters overlap each other. The unformatted text, extracted from the pdf document, reads: 'Conarebsounrfnaucme abreera=of6thoerw2a0fer sample, cm2.'	
	Discussion		
Action proposed	<input checked="" type="checkbox"/>	The committee agreed to do one of the following actions.	
		*No motion is required in this step.	
	<input checked="" type="checkbox"/>	No further action was taken by the committee.	
	<input type="checkbox"/>	Refer to the task force for more consideration.	
	<input type="checkbox"/>	New Business	
	<input type="checkbox"/>	Other	
	Editorial Change		
		Case 1: No vote in this section :	
		To be included and voted on in § 5. Summary of Editorial Changes.	
		Case 2: Voted in this section :	
	Original section number and at least one full sentence are required in “FROM” and “TO” fields.		
	1	FROM: Section xxx	
		To: Section xxx	
		Justification (If necessary)	
	2	FROM: Section xxx	
		To: Section xxx	

		Justification (If necessary)
Motion by/2nd	Friedrich Passek (Siltronic) / Mike Goldstein (Intel)	
Vote	14-0 Motion passed	
A&R		Not approved
	Reason:	

V. Summary of Editorial Changes

None

VI. Approval Conditions Check

APPROVAL CONDITION 1: All negatives have been discussed and were withdrawn, found not related, or not persuasive. (Regulations ¶ 9.6.2)

APPROVAL CONDITION 2: At least 90% of the sum of the valid accept and reject votes must be accept. (Regulations ¶ 9.6.3)

Note: if both approval conditions are not satisfied, the document fails.

		Accepts		(Accepts + Valid)		
Approval Rate	=	<input type="text" value="21"/>	/	<input type="text" value="21"/>	=	<input type="text" value="100.0%"/> >=90%

A&R		Not approved
	Reason:	

VII. Safety Check

See § 14 of the Regulations for further information

Motion:	<input checked="" type="checkbox"/>	This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.
	<input type="checkbox"/>	This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete.
	<input type="checkbox"/>	Safety Checklist (Regulations ¶ 14.3) is complete and has been included with the document throughout the balloting process.
Motion by/2nd by	Ryuji Takeda (GlobalWafers japan)/ Mike Goldstein (Intel)	
Discussion	None	
Vote	16-0 Motion passed	
A&R		Not approved
	Reason:	

VIII. Intellectual Property Check

Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information

<input checked="" type="checkbox"/>	The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.	
<input checked="" type="checkbox"/>	No potentially material patented technology or copyrighted items are known	GO TO SECTION IX
<input type="checkbox"/>	Potentially material patented technology or copyrighted items are known but a Letter of Assurance (LOA) or copyright release for such material has been obtained or presented to the committee.	GO TO SECTION IX
<input type="checkbox"/>	Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee	
MOTION	<input type="checkbox"/>	Ask ISC for special permission to publish
	<input type="checkbox"/>	Quit activity
	<input type="checkbox"/>	Wait for LOA for patented technology or release of copyrighted items.
	Motion by/2nd by	Name (Company)/Name (Company)
	Discussion	XXXX
	Vote	XX-XX
	Final Action	<input type="checkbox"/> Motion Passed
		<input type="checkbox"/> Motion Failed
A&R	<input type="checkbox"/>	Not approved
	Reason:	

* Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

IX. Action for this document

Motion	<input checked="" type="checkbox"/>	This document passed committee review as balloted and will be forwarded to the A&R for procedural review.	
	<input type="checkbox"/>	This document passed committee review with editorial changes and will be forwarded to the A&R for procedural review.	
	<input type="checkbox"/>	This document failed committee review and will be returned to the task force for rework.	
	<input type="checkbox"/>	This document failed committee review and work will be discontinued.	
	Motion by/2nd by	Ryuji Takeda (GlobalWafers Japan)/Fredrich Passek (Siltronic)	
	Discussion	None	
	Vote	16-0	
	Final Action	<input checked="" type="checkbox"/> Motion passed	
		<input type="checkbox"/> Motion failed	
A&R	<input type="checkbox"/>	Approved	
	<input type="checkbox"/>	Not approved	
	Reason:		

